



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 3, 2025

IGI Report Number **LG728531750**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.17 - 8.21 X 4.99 MM**

GRADING RESULTS

Carat Weight **2.04 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

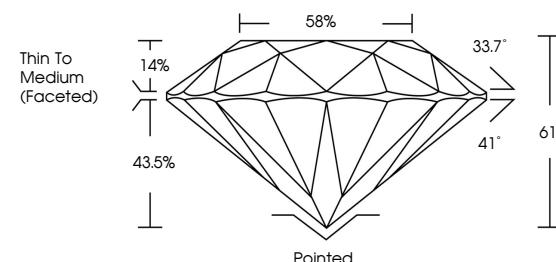
Symmetry **EXCELLENT**

Fluorescence **NONE**

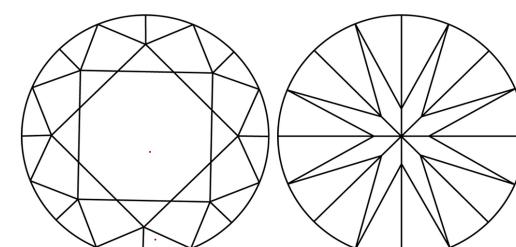
Inscription(s) **IGI LG728531750**

Comments: HEARTS & ARROWS
This Laboratory Grown Diamond was created by
Chemical Vapor Deposition (CVD) growth process.
Type Ila

PROPORTIONS



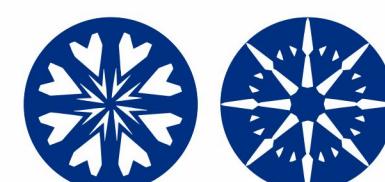
CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.



www.igi.org

LG728531750
Report verification at igi.org

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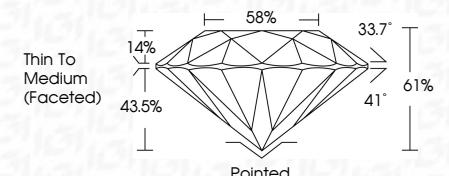
IDEAL

Clarity Grade **IDEAL**

Cut Grade **IDEAL**



Sample Image Used



ADDITIONAL GRADING INFORMATION

EXCELLENT

Polish **EXCELLENT**

NONE

Symmetry **EXCELLENT**

NONE

Fluorescence **EXCELLENT**

LG728531750

Inscription(s) **Comments: HEARTS & ARROWS**

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September 3, 2025	IGI Report No LG728531750	ROUND BRILLIANT	E	2.04 CARATS	Thin To Medium (Faceted)
Carat Weight	8.17 - 8.21 X 4.99 MM	Color Grade	VVS 2	IDEAL	61%
Clarity Grade		Cut Grade	IDEAL		68%
Depth		Table			
Table		Girdle			
Girdle		Pointed			
Polish		EXCELLENT			
Symmetry		EXCELLENT			
Fluorescence		NONE			
Inscription(s)		Comments: HEARTS & ARROWS			
		This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.			
		Type Ila			